



Atty. Docket No. 8013-1074

PATENTS

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#10/Ext (2)
Attel
4/1/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Hidemitsu AOKI et al.

Confirmation No. 6696

Serial No. 09/715,000

GROUP 2825

Filed November 20, 2000

Examiner Chuong A. Luu

IMPROVED SEMICONDUCTOR WAFER SURFACE
AND METHOD OF TREATING A SEMICONDUCTOR
WAFER SURFACE

11/19/99

PETITION FOR EXTENSION OF TIME

Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

The undersigned hereby petitions for an extension of time to respond to the Official Action of October 30, 2002 for two months to March 30, 2003.

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TECHNOLOGY CENTER 2800

Please charge the extension fee of \$410 to Deposit Account No. 25-0120. If this fee is insufficient, the Patent Office is hereby authorized to charge any additional extension fee to Deposit Account No. 25-0120. A duplicate copy of this sheet is enclosed.

A responsive paper is filed herewith.

Respectfully submitted,

YOUNG & THOMPSON

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By

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March 12, 2003